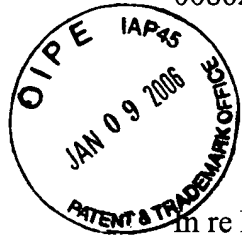


Co/C

00862.023258

PATENT



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent of:

Yuichi IWASAKI et al.

Application No.: 10/670,328

Filed: September 26, 2003

For: DEFLECTOR, METHOD OF MANUFACTURING  
DEFLECTOR, AND CHARGED PARTICLE BEAM  
EXPOSURE APPARATUS

U.S. Patent No. 6,953,938 B2

Issued: October 11, 2005

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450  
**Attention: Certificate of Correction Branch**

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) Examiner: P. M. Gurzo  
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) Group Art Unit: 2881  
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) January 9, 2006  
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LETTER CALLING ATTENTION TO ERRORS IN PATENT

Sir:

Patentees note the following errors in the above-identified patent:

COLUMN 10:

Line 62, "specifically," should read -- specifically, --.

COLUMN 16:

Line 7, "mask" should read -- mask, --.

Certificate  
JAN 13 2006  
of Correction

COLUMN 19:

Line 51, "water," should read -- water. --.

COLUMN 26:

Line 1, "has" should read -- has: --.

These errors are relatively insignificant. Therefore, Patentees believe that filing a Request for Certificate of Correction is not warranted. Rather, Patentees request that this paper be placed of record in the official file of the subject patent.

Patentees believe no fee is due for filing this paper. Nevertheless, the Commissioner is authorized to charge Deposit Account No. 06-1205 should any fee be deemed required.

Patentees' undersigned attorney may be reached in our Washington, D.C. Office by telephone at (202) 530-1010. All correspondence should continue to be directed to our below-listed address.

Respectfully submitted,



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